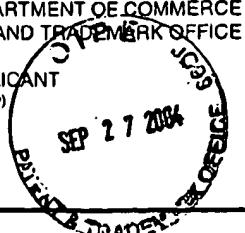


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-2440		SERIAL NO. 10/719,640	
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			APPLICANT: Terry L. Gilton et al.			
					FILING DATE November 21, 2003		GROUP 2813	
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate
AA	AA							
AB	AB							
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AH	AH							
AI	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country		Class	Subclass	Translation
AJ	AJ							Yes
AK	AK							No
AL	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
TSP	AM	Lee, Hyun-Yong et al., "Lithographic Properties of SiN _x and Se ₇₅ Ge ₂₅ Thin Films as the Low-Energy Ion-Beam Resist", Proceedings of the 5 th International Conference on Properties and Applications of Dielectric Materials, 25-30 May 1997, p.635-638						
	AN							
	AO							
EXAMINER		DATE CONSIDERED		 10/22/04				
'EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.'								